

APPLICATION DATA SHEET

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*Applicant Information:*Inventor 1:

Applicant Authority Type:	Inventor
Citizenship:	JP
Given Name:	Shinji
Family Name:	MAEKAWA
City of Residence:	Iwata, Shizuoka-ken
Country of Residence:	JP
Address-1 of Mailing Address:	3-12-3, Tousein-cyo
Address-2 of Mailing Address:	
City of Mailing Address:	Iwata-shi, Shizuoka-ken
State of Mailing Address:	
Postal Code of Mailing Address:	438-0039
Country of Mailing Address:	JP
Phone:	
Fax:	
E-mail:	

Correspondence Information:

Customer Number:	22204	*22204*
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Application Information:

Title of Invention:	MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE
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practitioner(s) at Customer Number:

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as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

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Assignee Information:**Assignee 1:**

Organization Name: Semiconductor Energy Laboratory Co., Ltd.

Address-1 of Mailing Address: 398, Hase

Address-2 of Mailing Address:

City of Mailing Address: Atsugi-shi, Kanagawa-ken

State of Mailing Address:

Postal Code of Mailing Address: 243-0036

Country of Mailing Address: JP

Phone:

Fax:

E-mail:

